



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re the Application of: **SEKINE, Norihiko**

Serial No.: 09/963,485

Group Art Unit: 2811

Filed: September 27, 2001

Examiner: **KANG, Donghee**

P.T.O. Confirmation No.: 9317

For: **SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF**

RESPONSE TO THE RESTRICTION REQUIREMENT
DATED DECEMBER 10, 2002

Commissioner for Patents
Washington, D.C. 20231

Date: January 7, 2003

Sir:

This paper is submitted in response to the Official Action dated **December 10, 2002**.

In the Action, restriction is required between Group (I), Claims 1-6, drawn to a semiconductor device; and Group (II), Claims 7-13, drawn to a method of making a semiconductor device.

Applicant hereby elects the subject matter of Group (I), Claims 1-6 for prosecution in this application. This election is made without traverse, it being understood that the applicant's rights to the filing of a divisional application directed to the non-elected subject matter under 35 USC 120 and 35 USC 121 are retained.

In the event that this paper is not timely filed, applicant hereby petitions for an appropriate extension of time. The fee for any such extension may be charged to our Deposit Account No. 01-2340.

RECEIVED
JAN - 8 2003
TECHNOLOGY CENTER 2800

2811
Donghee
#S
1/15/03

In the event any additional fees are required in connection with this response, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

ARMSTRONG, WESTERMAN & HATTORI, LLP



William G. Kratz, Jr.
Attorney for Applicant
Reg. No. 22,631

WGK/nrp

Atty. Docket No. **011292**
Suite 1000, 1725 K Street, N.W.
Washington, D.C. 20006
(202) 659-2930



23850

PATENT TRADEMARK OFFICE